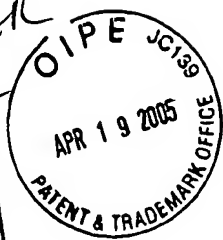


OK TO  
ENTER  
5/13/05  
1W4



Corres. and Mail  
**BOX AF**

AF 11763 <sup>1763</sup>

AMENDMENT UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
GROUP 1763  
PATENT APPLICATION

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of

Docket No: Q77313

Shinya YAMASAKI, et al.

Appln. No.: 10/665,148

Group Art Unit: 1763

Confirmation No.: 5798

Examiner: LUND, Jeffrie R.

Filed: September 22, 2003

For: ETCHING AND CLEANING METHODS AND ETCHING AND CLEANING  
APPARATUS USED THEREFOR

**AMENDMENT UNDER 37 C.F.R. § 1.116**

**MAIL STOP AF**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated January 19, 2005, please amend the above-  
identified application as follows on the accompanying pages.

**TABLE OF CONTENTS**

AMENDMENTS TO THE SPECIFICATION.....	2
AMENDMENTS TO THE CLAIMS .....	3
REMARKS .....	7